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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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of

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Complete if Known
09/943,187
August 29, 2001
Kristy A. Campbell, et al.
2822
Khanh B. Duong
M4065.0703/P703

	_		U.S. PA	ATENT DOCUMENTS	2
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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Examiner	Cite	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant	
Initials*	No.'	Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	WINDE-1111	Applicant of Cited Document	Figures Appear	T°
KBI	ВА	WO 97/48032	12/18/1997	Kozicki et al.		
1	BB	WO 99/28914	06/10/1999	Kozicki et al.		

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*EXAMINER: Initial irreference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

Applicant's unique citation designation number (optional). ²See attached Kinds Codes of USPTO Patent Documents at www.uspibc.com or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the application number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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Sheet	2	of	8	Attorney Docket Number	M4065.0703/P703	66 ~				

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